**AMENDMENT TRANSMITTAL LETTER**Docket No.  
SON-1908/DIVApplication No.  
10/759,194-Conf. #7751Filing Date  
January 20, 2004Examiner  
F. L. ToledoArt Unit  
2823


Applicant(s): Takeshi Nogami et al.

Invention: METHOD FOR PRODUCING SEMICONDUCTOR DEVICE, POLISHING APPARATUS,  
AND POLISHING METHOD**TO THE COMMISSIONER FOR PATENTS**

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	30	- 33 =	0	x 0.00	0.00
Independent Claims	4	- 4 =	0	x 0.00	0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					0.00

☒ Large Entity☐ Small Entity☐ No additional fee is required for this amendment.☐ Please charge Deposit Account No. \_\_\_\_\_ in the amount of \$ \_\_\_\_\_.  
A duplicate copy of this sheet is enclosed.☐ A check in the amount of \$ \_\_\_\_\_ to cover the filing fee is enclosed.☐ Payment by credit card. Form PTO-2038 is attached.☒ The Director is hereby authorized to charge and credit Deposit Account No. 18-0013  
as described below. A duplicate copy of this sheet is enclosed.☒ Credit any overpayment.☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.  
Ronald P. Kananen  
Attorney Reg. No.: 24,104Dated: March 22, 2006RADER, FISHMAN & GRAUER PLLC  
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Docket No.: SON-1908/DIV  
(PATENT)

AF  
JFW

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Takeshi Nogami et al.

Application No.: 10/759,194

Confirmation No.: 7751

Filed: January 20, 2004

Art Unit: 2823

For: METHOD FOR PRODUCING  
SEMICONDUCTOR DEVICE, POLISHING  
APPARATUS, AND POLISHING METHOD

Examiner: F. L. Toledo

**AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated January 9, 2006, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 11 of this paper.